

# *AdvLIGO Laser Status*

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# *Outline*

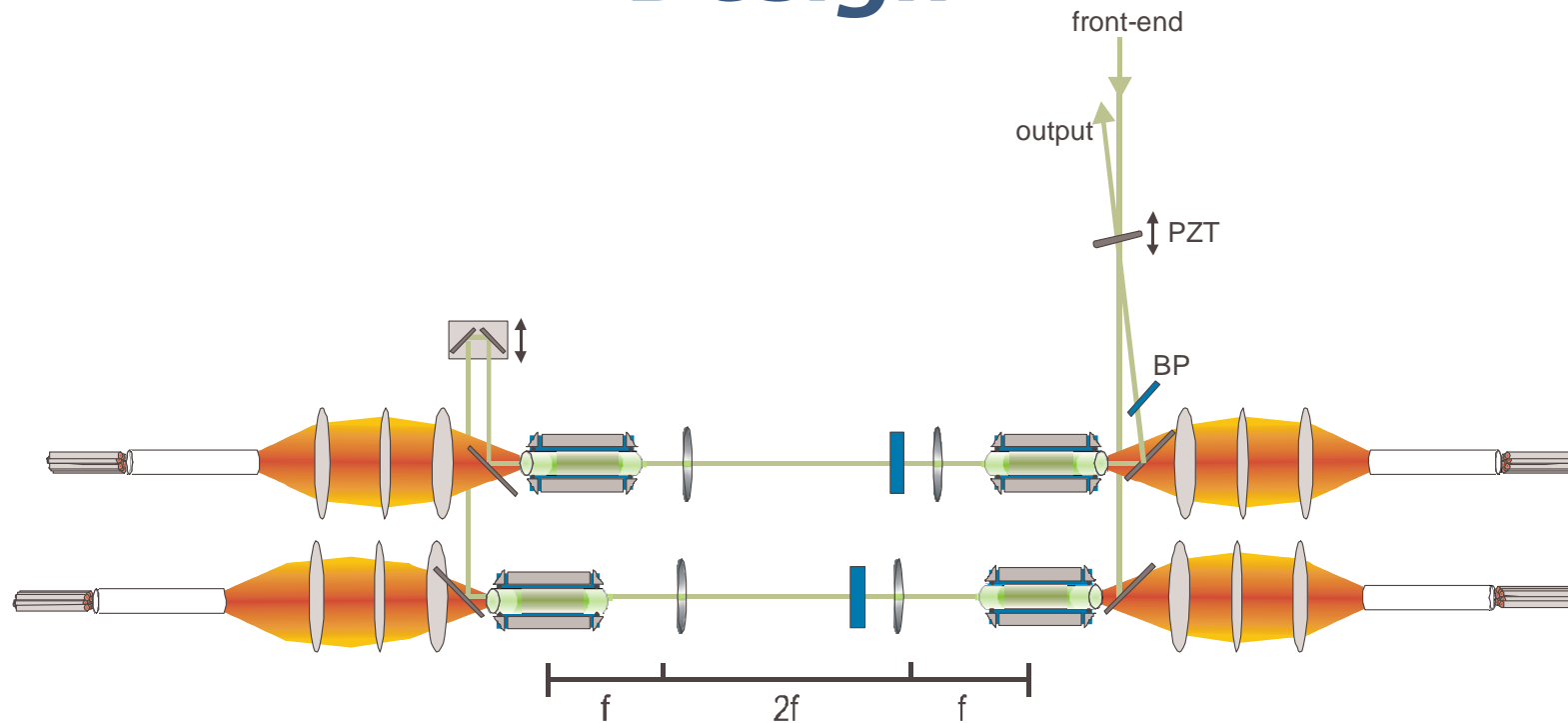
- Optimization History of the advLIGO laser
  - New laser design approach
  - Component related complications
  - Quality inspection measures for new components
  - Final results of new approach

# *History*

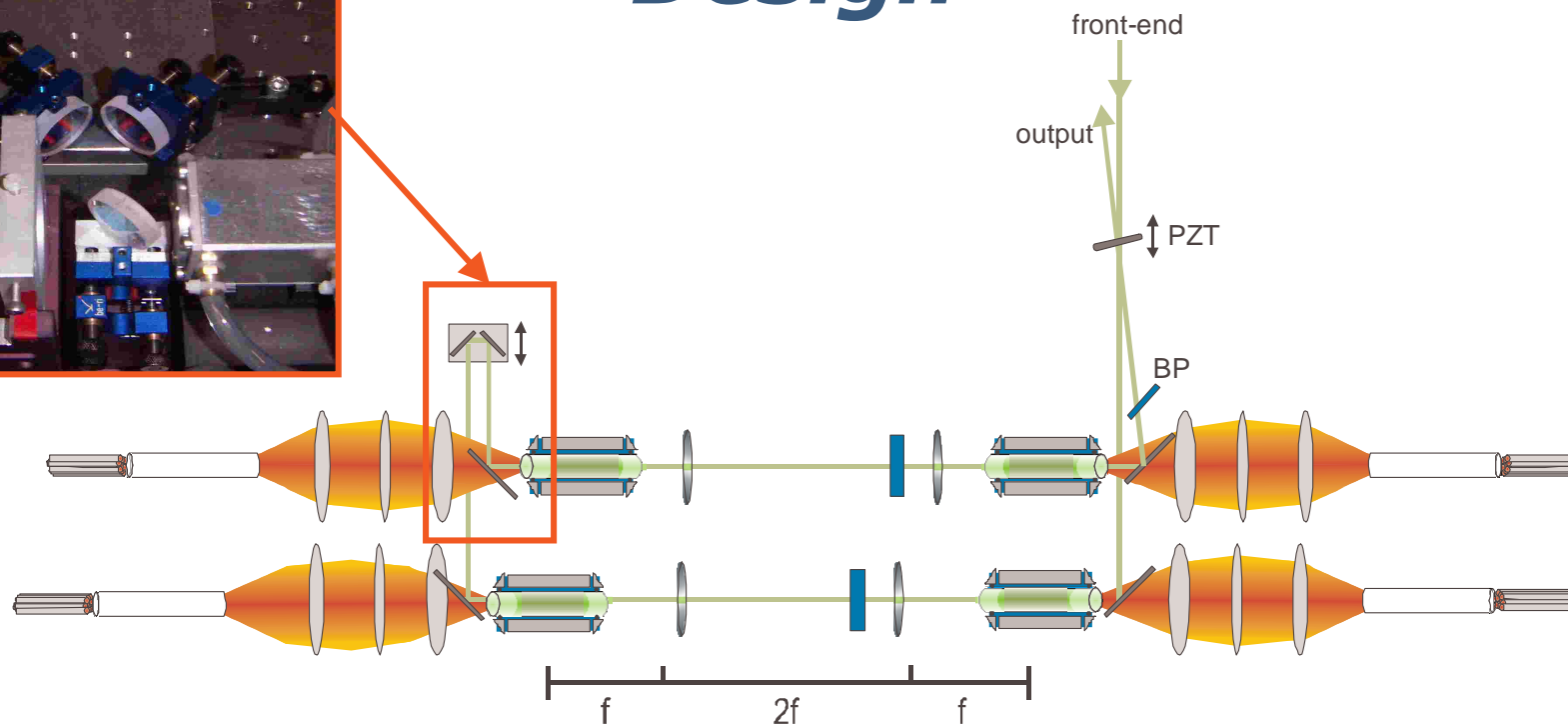
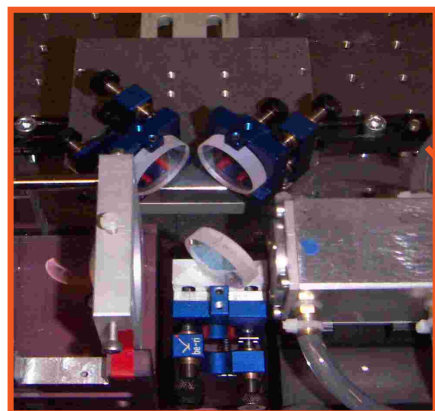
New resonator design to improve beam profile / mode control

- Asymmetric resonator design

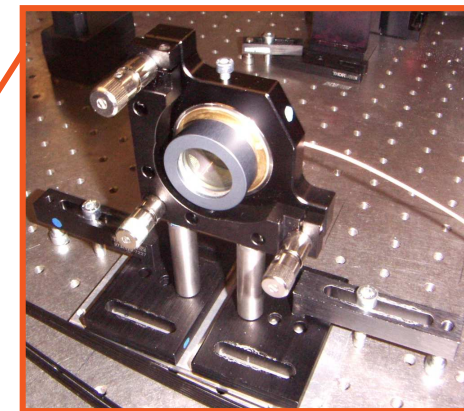
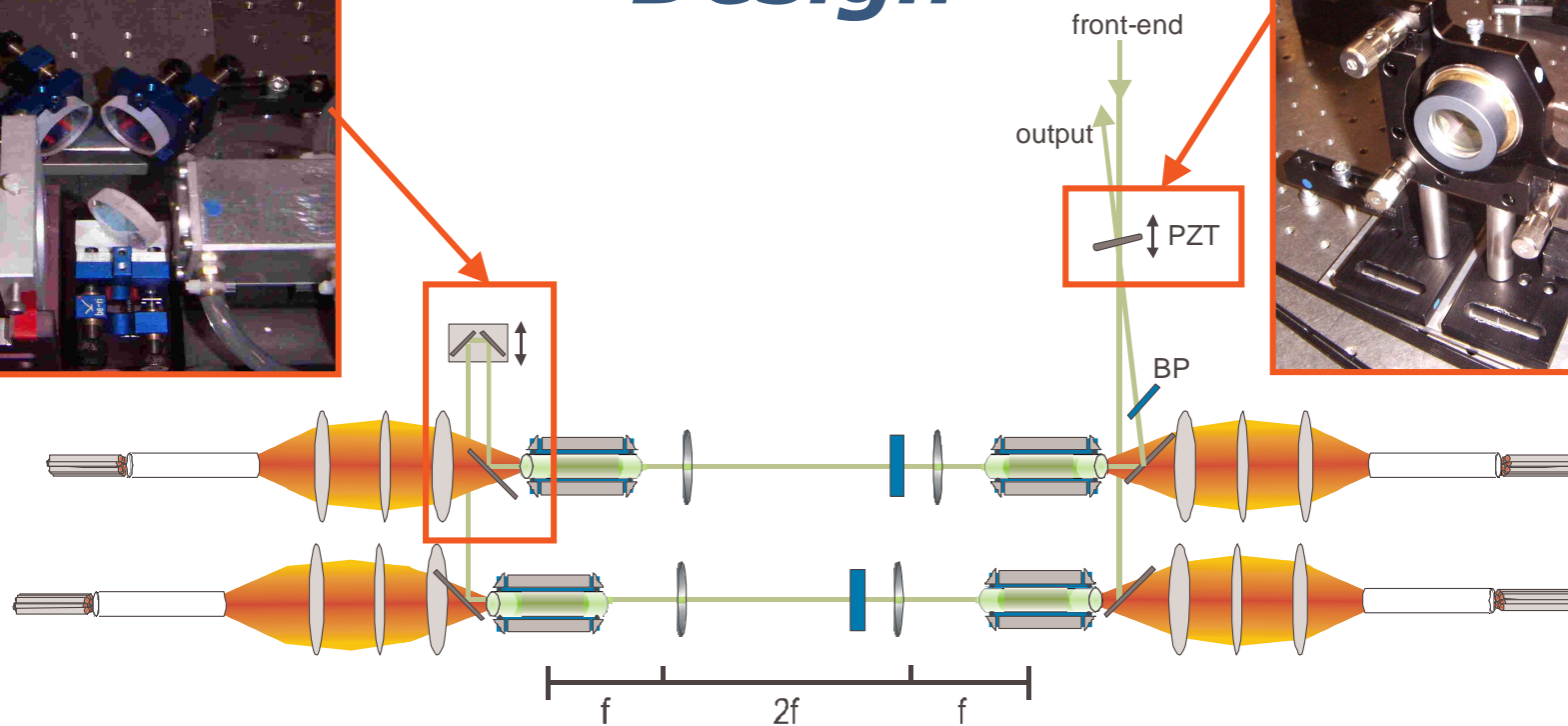
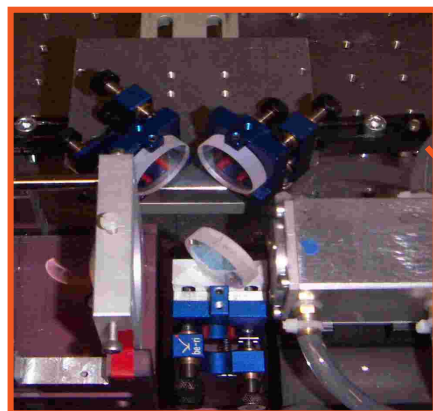
# New Resonator Design



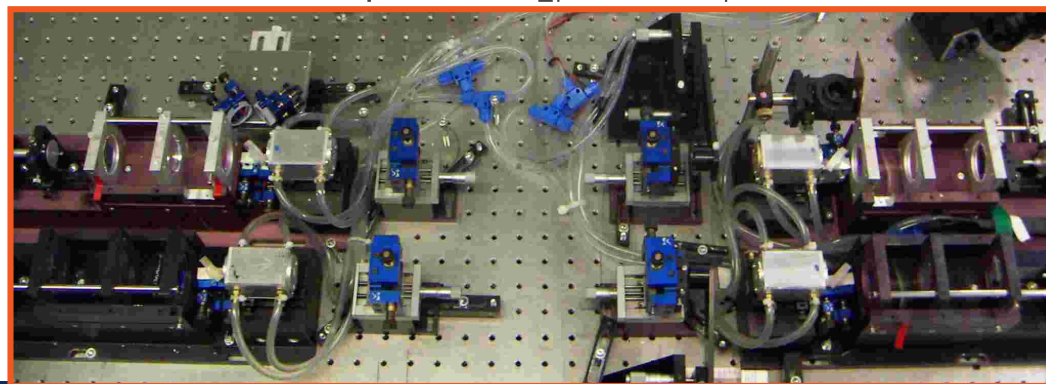
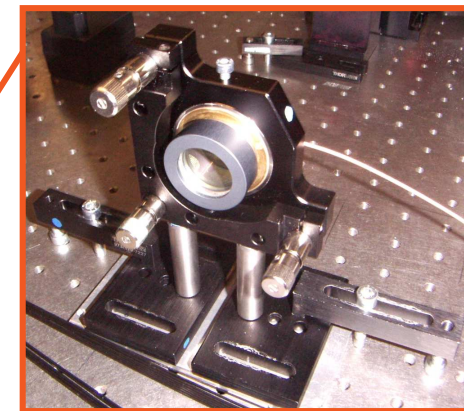
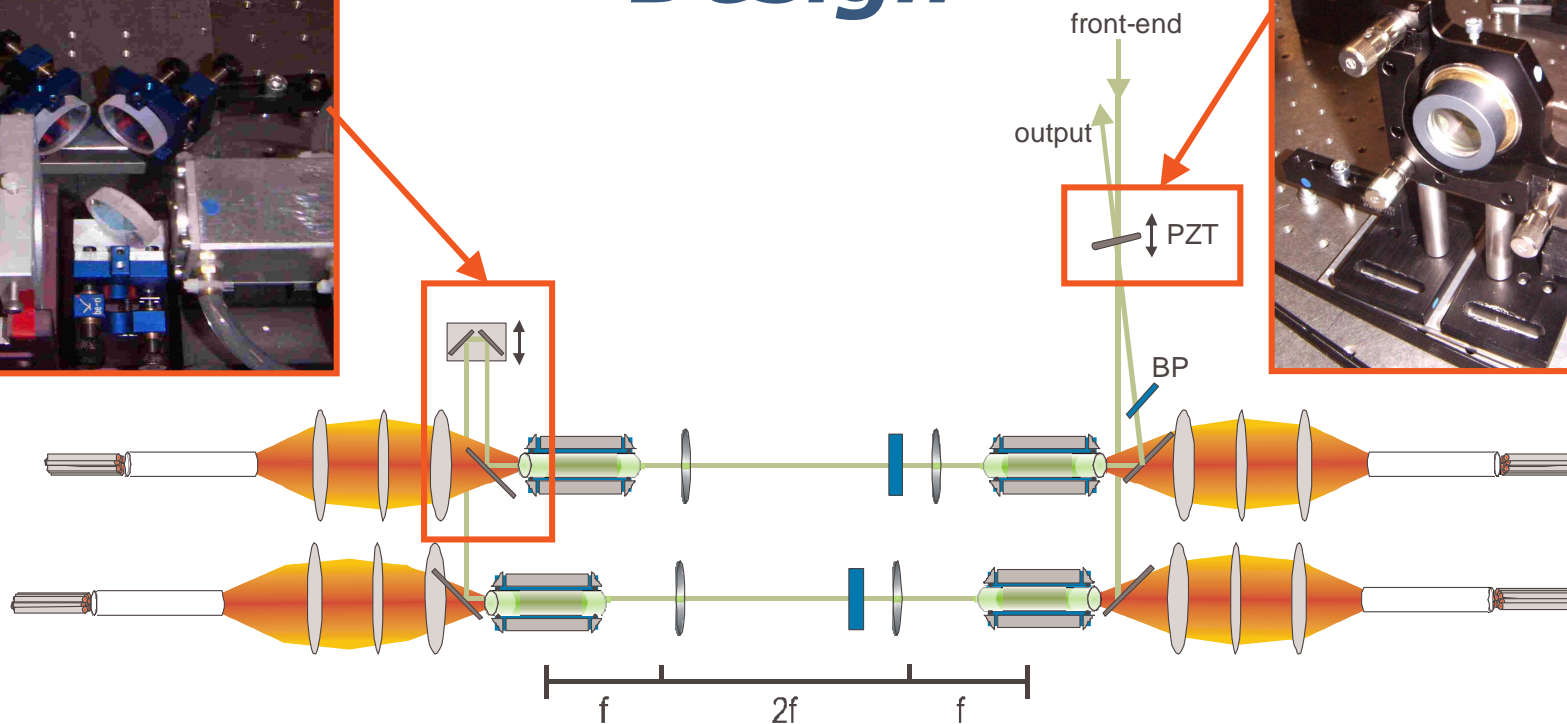
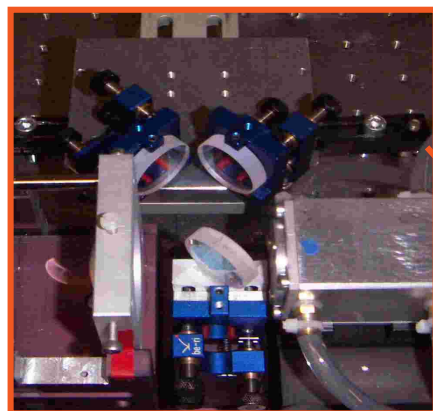
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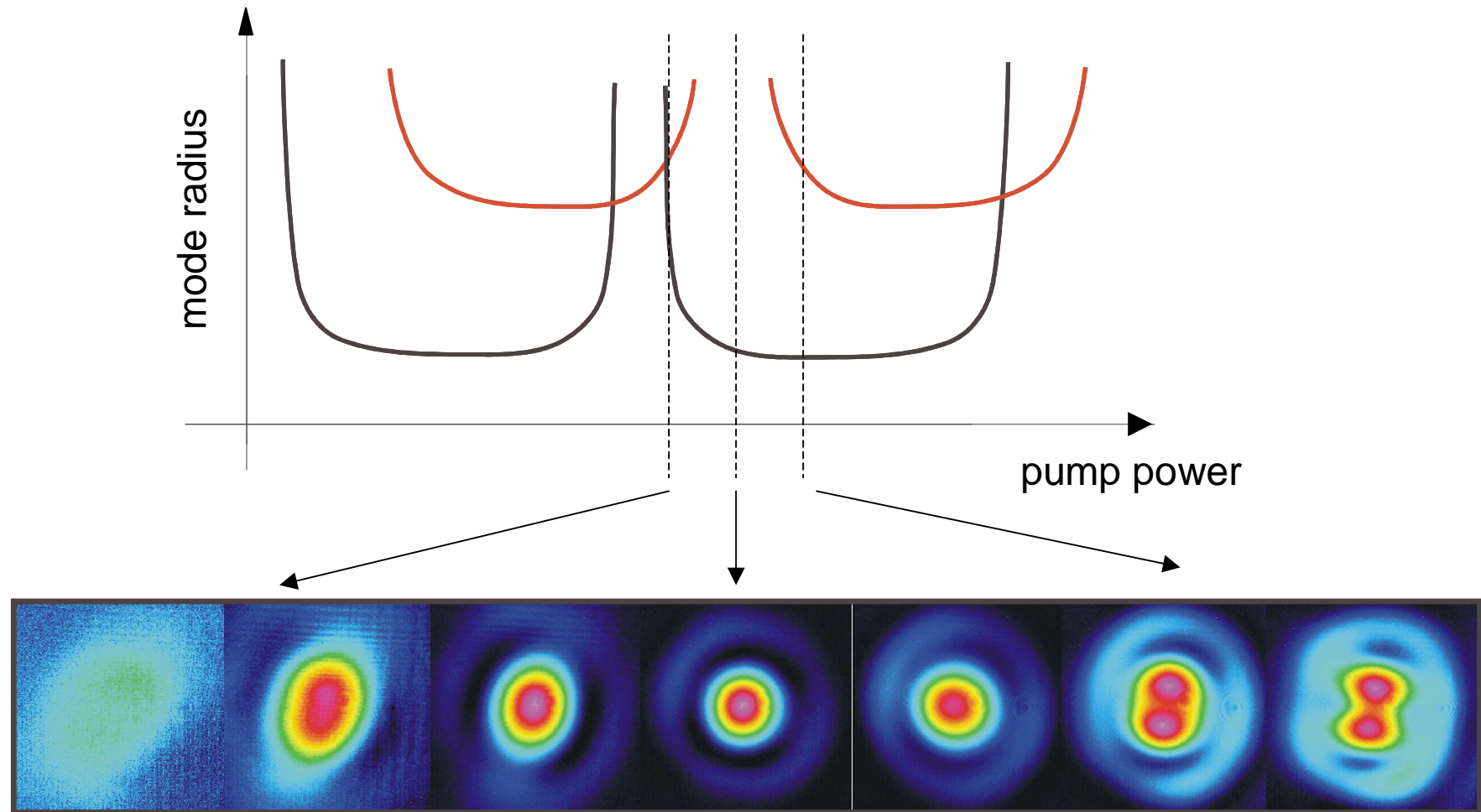


# New Resonator Design





# Better mode control





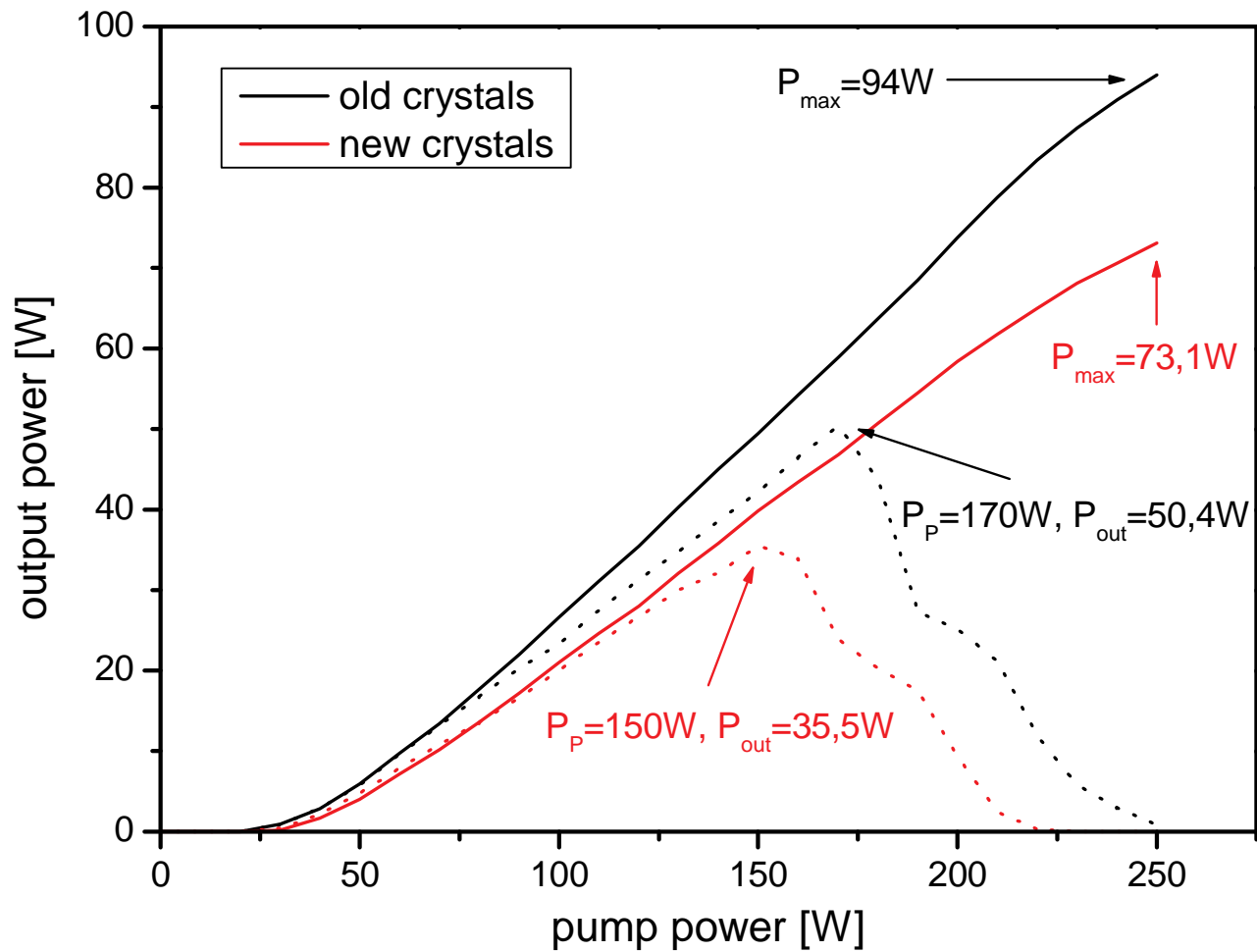
# History

- New resonator design to improve beam profile / mode control
  - Asymmetric resonator design => output power  $\approx$  **115 W**
- Difficulties with low damage threshold of 45° mirr or coatings
  - Mirrors changed to high power IPG coated ones

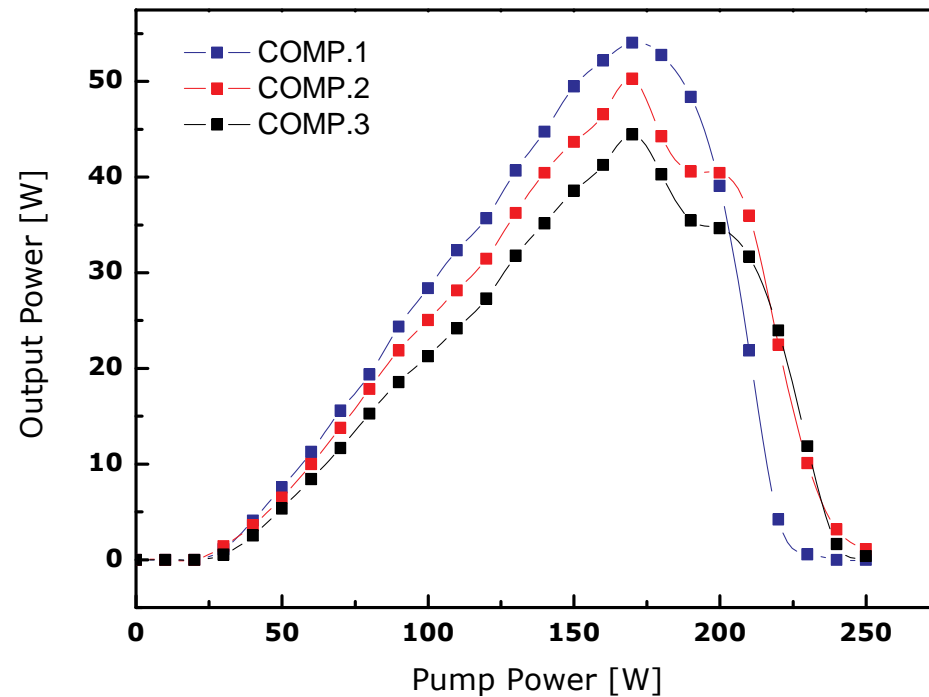
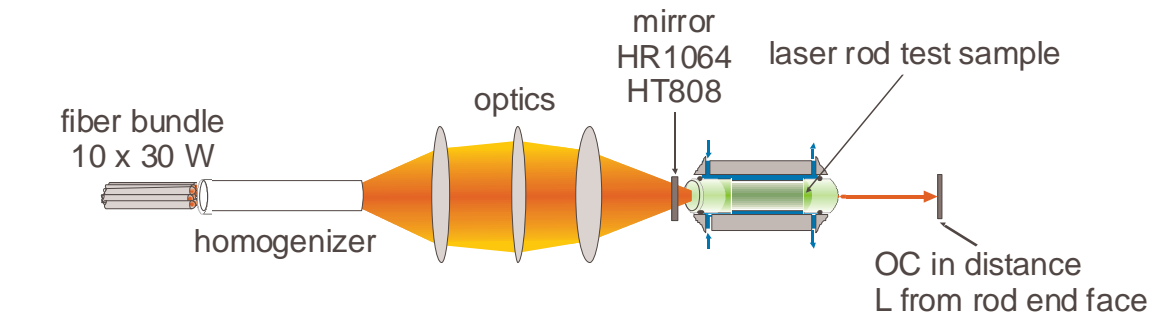
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- Difficulties with low damage threshold of 45° mirr or coatings
  - Mirrors changed to high power IPG coated ones
- Power-loss due to impurities in laser crystal material
  - minimal Er/Yb contamination in crystal material
  - decrease in output power by unknown absorption effects
  - higher thermal-lensing

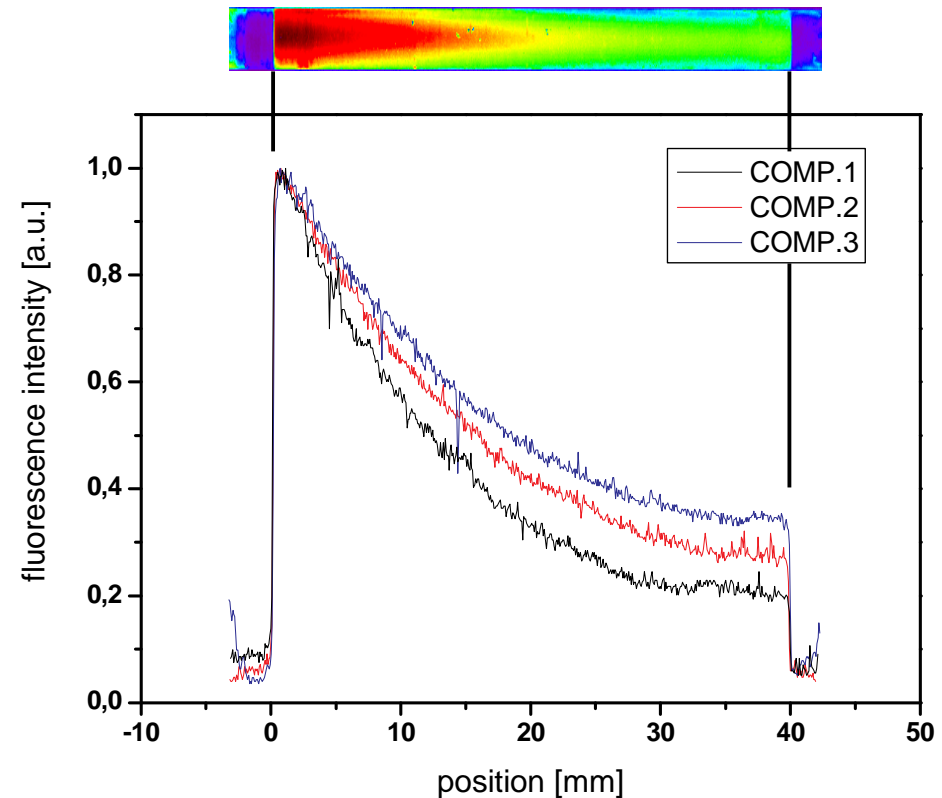
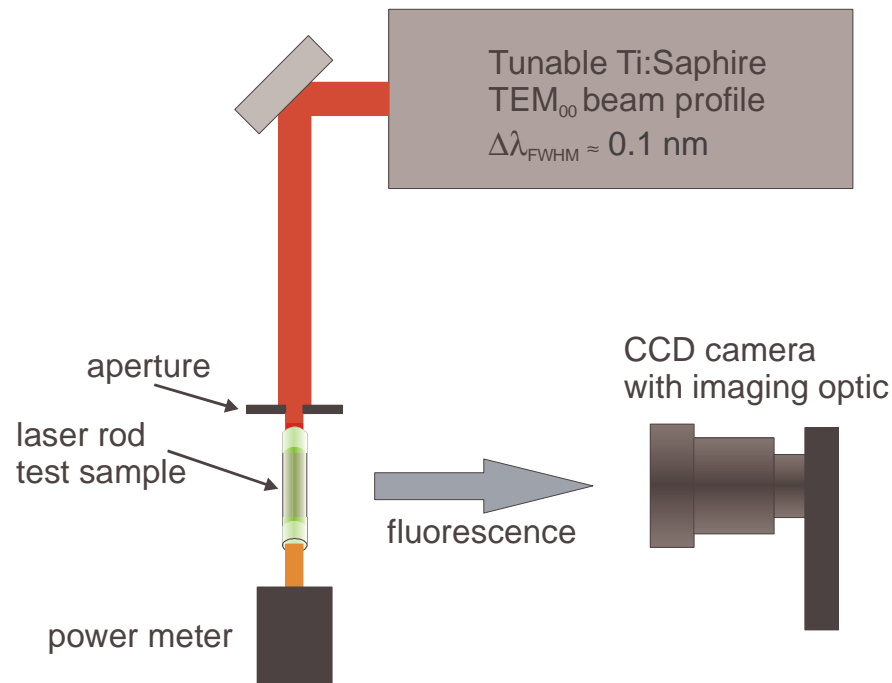
# Comparison of laser crystals old and new



# Quality inspection measures for new components: laser crystals



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Variation of up to +/-10% in doping concentration for rods from different vendors

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- Power-loss due to impurities in laser crystal material
  - after component (mirrors / Nd:YAG rod) change output power  $\approx$  **125 W**

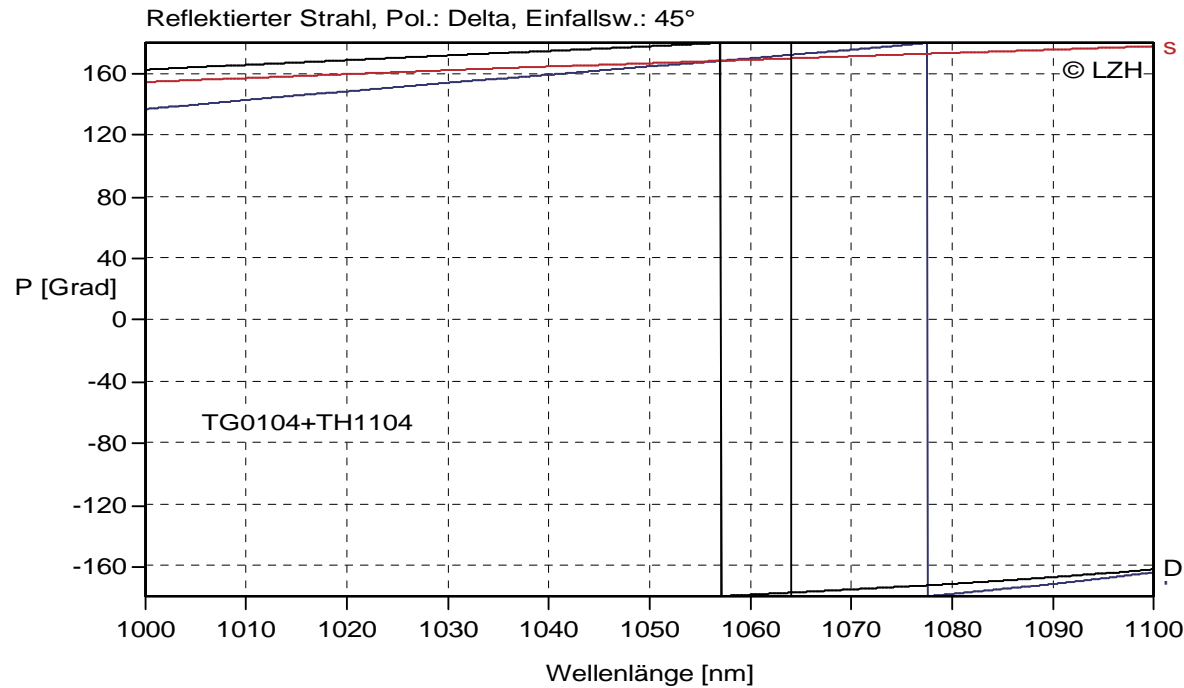
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- Limitation of output power due to depolarization effects
  - 45°HR1064nm / HT808nm => phase shift difference f or p- and s-polarization up to **30°**
  - mirrors act as  $\lambda/4$ -waveplates
  - additional depolarization losses



# Mirrors

Old mirror with low damage threshold:  
phase difference  $3^\circ$  for s- and p-polarization

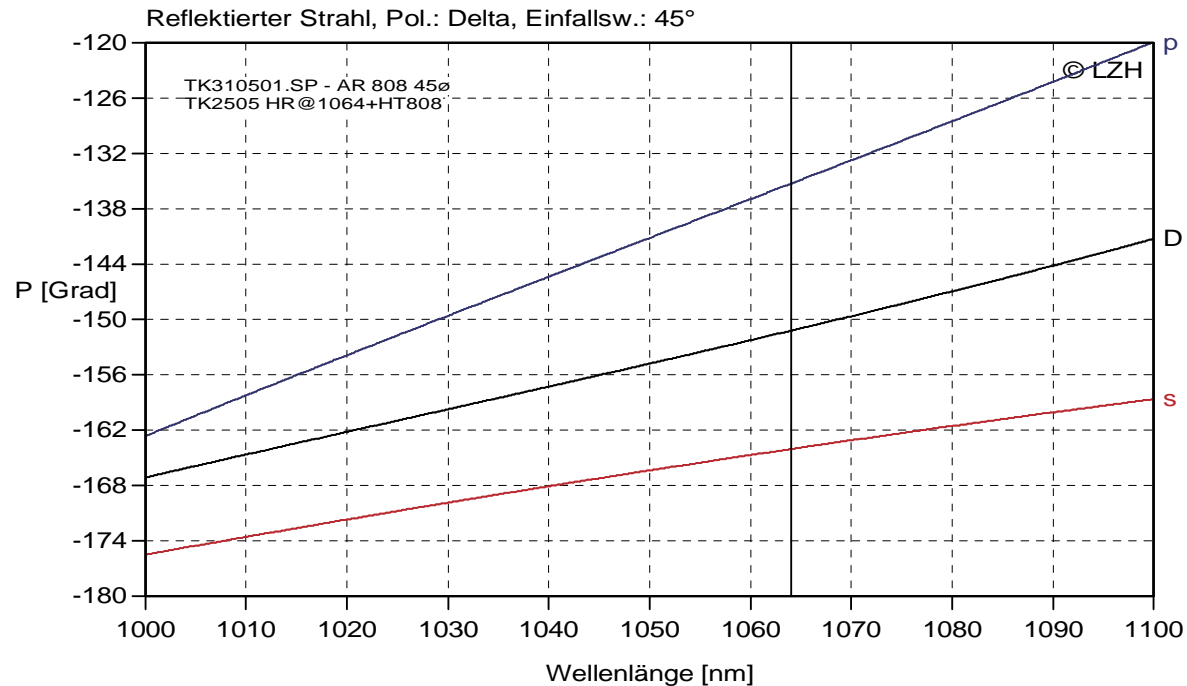


1064.04 nm : 172.2096, 169.9302, -177.7206

- Phase in Reflexion, V/R-Schichten 29/4, Zentralw.: 1054nm, Pol.: p-pol., Einfallsw.:  $45^\circ$
- Phase in Reflexion, V/R-Schichten 29/4, Zentralw.: 1054nm, Pol.: s-pol., Einfallsw.:  $45^\circ$
- Phase in Reflexion, V/R-Schichten 29/4, Zentralw.: 1054nm, Pol.: Delta, Einfallsw.:  $45^\circ$

# Mirrors

New high power mirror with IPG coating:  
phase difference 30° for s- and p-polarization

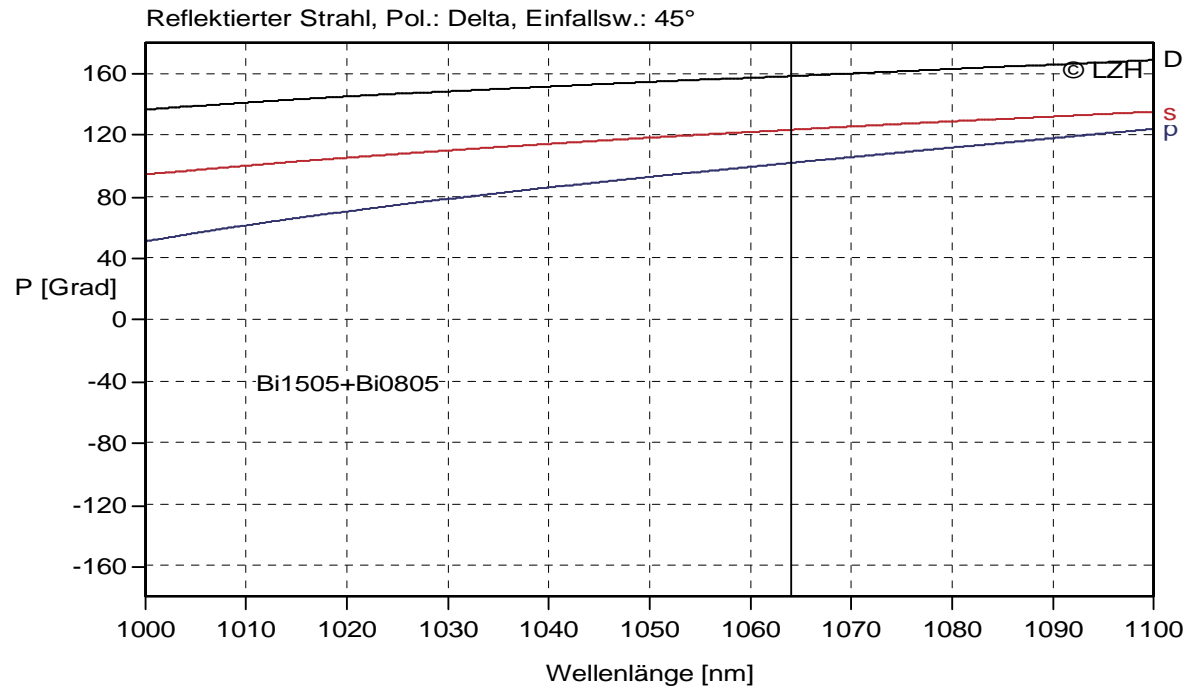


1064.04 nm : -135.2536, -164.0485, -151.2051

- Phase in Reflexion, V/R-Schichten 4/30, Zentralw.: 808nm, Pol.: p-pol., Einfallsw.: 45°
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# Mirrors

Mirrors actually used:  
phase difference  $20^\circ$  for s- and p-polarization

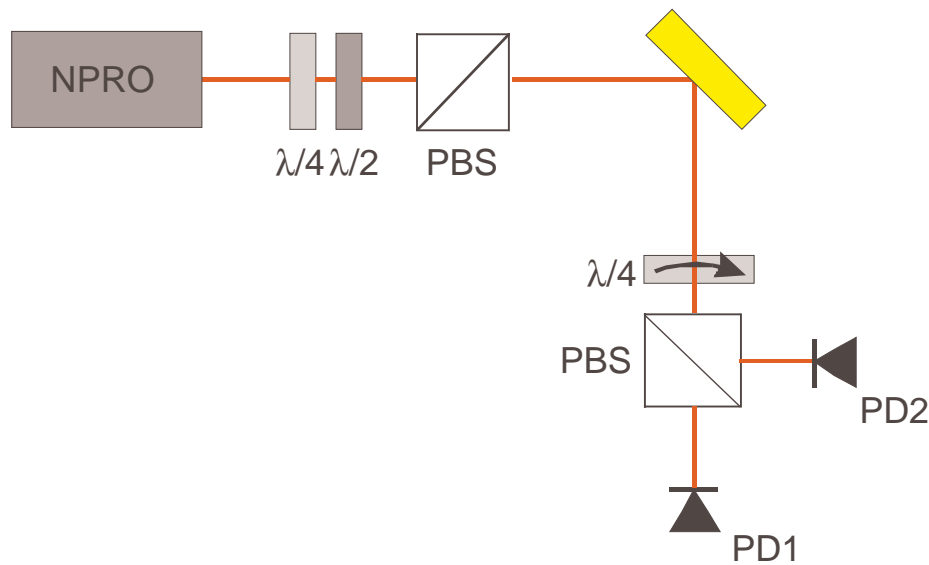


1064.04 nm : 101.918, 123.4582, 158.4599

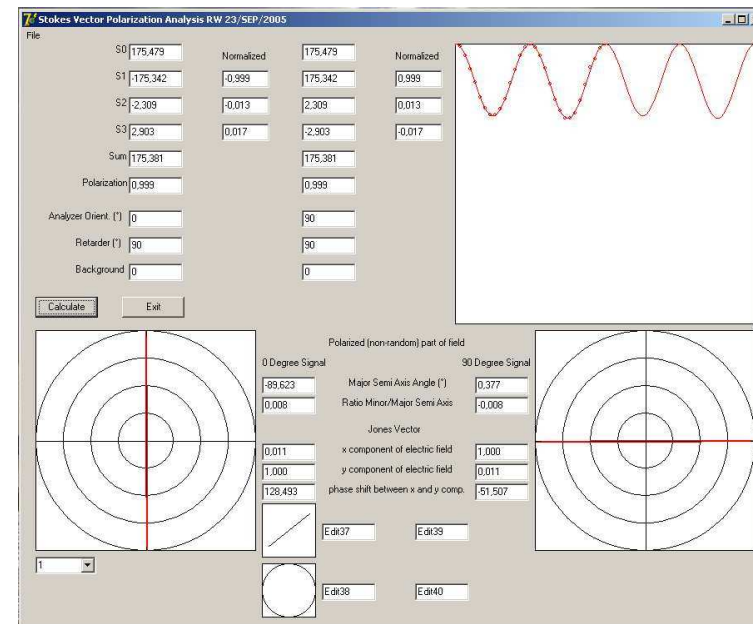
- Phase in Reflexion, V/R-Schichten 30/2, Zentralw.: 1170nm, Pol.: p-pol., Einfallsw.:  $45^\circ$
- Phase in Reflexion, V/R-Schichten 30/2, Zentralw.: 1170nm, Pol.: s-pol., Einfallsw.:  $45^\circ$
- Phase in Reflexion, V/R-Schichten 30/2, Zentralw.: 1170nm, Pol.: Delta, Einfallsw.:  $45^\circ$

# Quality inspection measures for new components: mirror's

automated polarimeter



polarization analysis software



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  - Mirrors changed to high power IPG coated ones
- Power-loss due to impurities in laser crystal material
  - after component (mirrors / Nd:YAG rod) change output power  $\approx 125\text{ W}$
- Limitation of output power due to depolarization effects
  - Increased output power by use of mirrors with  $20^\circ$  phase shift to  $\approx 150\text{ W}$

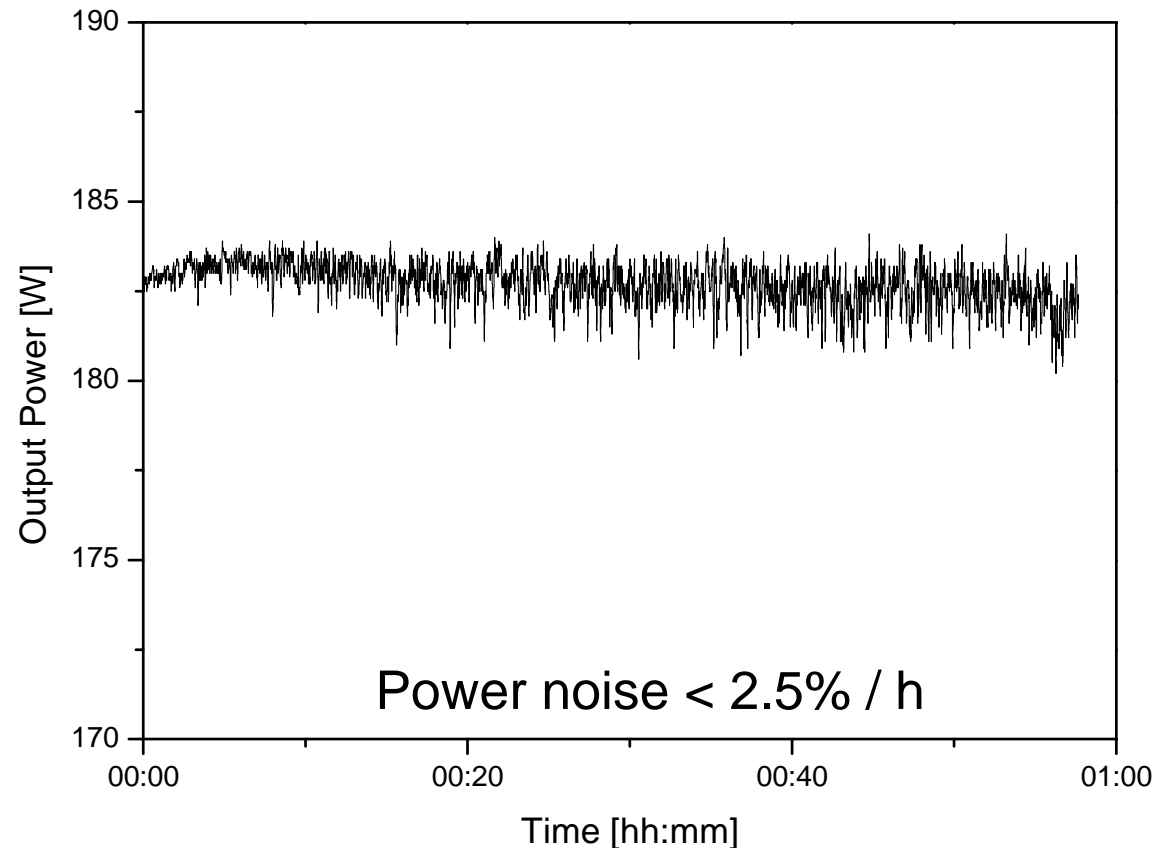
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- Improvement of locking range
  - Replaced front-end by 35 W Nd:YVO<sub>4</sub> amplifier



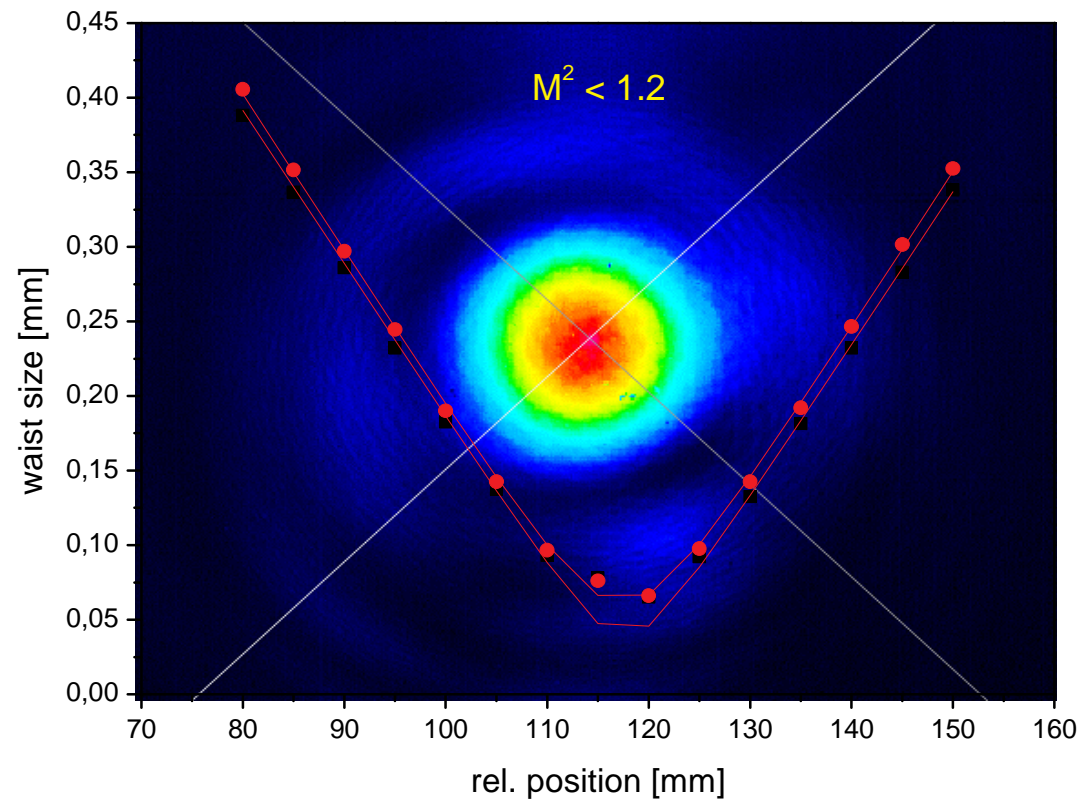


# *Injection-Locked Single Frequency Output-Power*



Single-frequency TEM<sub>00</sub> output power 183 W

# Beam Quality



Optimization of front-end to HPL mode-matching:  
Further improvements in output power and beam quality possible

# *Summary and Outlook*

- 35 W front-end implemented
- 183 W linearly polarized output power  
( >200 W expected due to new mirrors )
- Beam quality  $M^2 < 1.2$  (has to be optimized)
  
- **Quality inspection measures for incoming components**
- Further investigation on PET mirror resonance
- More accurate mode-matching of front-end and HPL